

FORM PTO-1449 (Modified)
U.S. Department of Commerce, Patent and Trademark Office

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IB-1632

09/739,391

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use several sheets if necessary)

Applicant

Ronald P. Reade et al.

Filing Date
December 15,
2000Group
Unknown

U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,262,394	11/16/93	Wu et al.	505	1	12/27/91
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AR	Wiesmann, J., et al., "Large-Area Deposition of Biaxially Textured YSZ Buffer Layers Using an IBAD-Process", <u>Nucl. Instr. and Meth. in Phys. Res. B</u> 120, 1996, pp. 290-292.
AS	
AT	

Examiner

Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.